



RECEIVED
JUL 17 2003
TC 1700

520.36911VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. ONO, et al
Serial No.: 09/691,119
Filed: October 19, 2000
For: METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR
Group: 1763
Examiner: A. Olsen

#713
7/18/03
MW

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 16, 2003

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application in response to the Office Action dated April 16, 2003.